

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

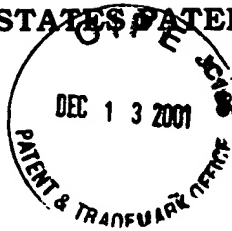
In re the application of:

Teiichirou Chiba *et al.*

Serial No.: 09/492,761

Filed: January 27, 2000

For: SEMICONDUCTOR WAFER



#5

12-20-01

Examiner: C. Chu *T. Flower*

Art Group Unit: 2815

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REQUEST FOR APPROVAL OF DRAWING CHANGES

Honorable Commissioner
of Patents and Trademarks
Washington, D.C. 20231

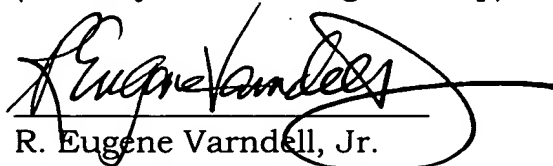
December 13, 2001

Dear Sir:

Please find two sheets of drawings attached hereto encompassing Figs. 6 and 7. It is respectfully requested that the changes marked in red on the attached figures be approved.

Acknowledgement of receipt and approval of this Request are respectfully requested.

Respectfully submitted,
VARNDELL & VARNDELL, PLLC
(formerly Varndell Legal Group)


R. Eugene Varndell, Jr.
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Registration No. 29,728

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